## **Environmental Protection Agency**

## Pt. 63, Subpt. EEEE, Table 9

For each	If you	You have demonstrated initial compliance if
	b. Install and, during the loading of organic liquids, operate a vapor balancing system.	You design and operate the vapor balancing system to route organic HAP vapors displaced from loading of organic liquids into transport vehicles to the storage tank from which the liquid being loaded originated or to another storage tank connected to a common header.      You design and operate the vapor balancing system to route organic HAP vapors displaced from loading of organic liquids into containers directly (e.g., no intervening tank or containment area such as a room) to the storage tank from which the liquid being loaded originated or to another storage tank connected to a common header.
	c. Route emissions to a fuel gas system or back to a process.	i. See item 1.b.i of this table.
<ol> <li>Equipment leak component, as defined in §63.2406, that operates in organic liquids service ≥300 hours per year at an existing, reconstructed, or new af- fected source.</li> </ol>	Carry out a leak detection and repair program or equivalent control accord- ing to one of the subparts listed in table 4 to this subpart, item 4.a.	You specify which one of the control programs listed in table 4 to this sub- part you have selected, OR     Provide written specifications for your equivalent control approach.

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m July}~28,~2006,~{
m as}~{
m amended}~{
m at}~73~{
m FR}~21833,~{
m Apr.}~23,~2008]$ 

## Table 8 to Subpart EEEE of Part 63—Continuous Compliance With Emission Limits

As stated in  $\S63.2378(a)$  and (b) and 63.2390(b), you must show continuous compliance with the emission limits for existing, reconstructed, or new affected sources according to the following table:

	pliance by
a. Reduce total organic HAP (or, upon approval, TOC) emissions from the closed vent system and control device by 95 weight-percent or greater, or as an option to 20 ppmv or less of total organic HAP (or, upon approval, TOC) in the exhaust of combustion devices.  a. Reduce total organic HAP (or, upon approval, TOC) emissions during the loading of organic liquids from the closed vent system and control device by 98 weight-percent or greater, or as an option to 20 ppmv or less of total organic HAP (or, upon approval, TOC) in the exhaust of combustion devices.	i. Performing CMS monitoring and collecting data according to §§ 63.2366, 63.2374, and 63.2378; AND ii. Maintaining the operating limits established during the design evaluation or performance test that demonstrated compliance with the emission limit. i. Performing CMS monitoring and collecting data according to §§ 63.2366, 63.2374, and 63.2378 during the loading of organic liquids; AND ii. Maintaining the operating limits established during the design evaluation or performance test that demonstrated compliance with the emission limit during the loading of organic liquids.
	approval, TOC) emissions from the closed vent system and control device by 95 weight-percent or greater, or as an option to 20 ppmv or less of total organic HAP (or, upon approval, TOC) in the exhaust of combustion devices.  a. Reduce total organic HAP (or, upon approval, TOC) emissions during the loading of organic liquids from the closed vent system and control device by 98 weight-percent or greater, or as an option to 20 ppmv or less of total organic HAP (or, upon approval, TOC)

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## Table 9 to Subpart EEEE of Part 63—Continuous Compliance With Operating Limits—High Throughput Transfer Racks

As stated in  $\S 63.2378(a)$  and (b) and 63.2390(b), you must show continuous compliance with the operating limits for existing, reconstructed, or new affected sources according to the following table: